**PATENT** 

Attorney Docket No.: 019930-002820 Client Reference No.: A1297 D2

I hereby certify that this is being deposited with the United States Postal Service "Express Mail Post Office to Address" service under 37 CFR 1.10 on the date indicated above and is addressed to:

Commissioner for Patents

P.O. Box 1450

Alexandria, V 22313-1450

Aurora Lowell

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

David Miller, et al.

Application No.: Not Yet Assigned

Filed: Herewith

For: SYSTEMS AND METHODS FOR

**OVERCOMING STICTION** 

Examiner: Not Yet Assigned

Art Unit: Not Yes Assigned

INFORMATION DISCLOSURE

STATEMENT UNDER 37 CFR §1.97 and

§1.98

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

The references cited on attached form PTO/SB/08A and PTO/SB/08B are being called to the attention of the Examiner. This application is a divisional application of and relies on U.S. Appl. No. 10/087,040, filed February 28, 2002 (the "parent application") for an effective filing under 35 U.S.C. § 120. All of the references were submitted to or cited by the U.S. Patent and Trademark Office in the parent application. Therefore, pursuant to 37 CFR § 1.98(d), copies of the references are not enclosed. It is respectfully requested that the cited references be

PATENT

David Miller, et al.

Application No.: Not Yet Assigned

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expressly considered during the prosecution of this application, and the references be made of

record therein and appear among the "references cited" on any patent to issue therefrom.

As provided for by 37 CFR 1.97(g) and (h), no inference should be made that the

information and references cited are prior art merely because they are in this statement and no

representation is being made that a search has been conducted or that this statement encompasses

all the possible relevant information.

Applicant believes that <u>no fee is required</u> for submission of this statement.

However, if a fee is required, the Commissioner is authorized to deduct such fee from the

undersigned's Deposit Account No. 20-1430. Please deduct any additional fees from, or credit

any overpayment to, the above-noted Deposit Account.

Respectfully submitted,

Irvin E. Branch Reg. No. 42,358

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IEB:arl 60087181 v1

| Substitu | ite for form 1449A/PT | го     |              |                        | Complete if Known |
|----------|-----------------------|--------|--------------|------------------------|-------------------|
|          |                       |        |              | Application Number     | Not Yet Assigned  |
| INFO     | ORMATION              | I DI   | SCLOSURE     | Filing Date            | Herewith          |
| STA      | TEMENT E              | BY A   | PPLICANT     | First Named Inventor   | Miller, David     |
|          |                       |        |              | Art Unit               | Not Yet Assigned  |
| _        | (use as many sh       | eets a | s necessary) | Examiner Name          | Not Yet Assigned  |
| Sheet    | 1                     | of     | 3            | Attorney Docket Number | 019930-002820     |

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|              |                   |        | CLOSURE    | Filing Date            | Herewith         |  |
| SIAII        | EMENI B           | ΥA     | PPLICANT   | First Named Inventor   | Miller, David    |  |
|              |                   |        |            | Art Unit               | Not Yet Assigned |  |
| (u           | se as many she    | ets as | necessary) | Examiner Name          | Not Yet Assigned |  |
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Applicant's unique citation designation number (optional). Applicant is to place a check mark here if English language Translation is attached.

| Substitute f | or form 1449B/PTC | )      |            | Complete if Known      |                  |  |
|--------------|-------------------|--------|------------|------------------------|------------------|--|
|              |                   | DIO    |            | Application Number     | Not Yet Assigned |  |
|              |                   |        | CLOSURE    | Filing Date            | Herewith         |  |
| STAT         | EMENT B           | YA     | PPLICANT   | First Named Inventor   | Miller, David    |  |
|              |                   |        |            | Art Unit               | Not Yet Assigned |  |
| (u           | ise as many she   | ets as | necessary) | Examiner Name          | Not Yet Assigned |  |
| Sheet        | 3                 | of     | 3          | Attorney Docket Number | 019930-002820    |  |

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| Examiner Initials * | Cite<br>No.1 | Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published. | T 2 |
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| Examiner  | Date       |  |
|-----------|------------|--|
| Signature | Considered |  |

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